

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:)
Yoshihisa NAGANO et al.) Group Art Unit: 2826
Application No. 10/829,476) Examiner: Scott R. Wilson
Filed: April 22, 2004) Confirmation No. 5876
For: SEMICONDUCTOR DEVICE AND)
METHOD OF FABRICATING THE)
SAME)

AMENDMENT

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the Office Action dated November 25, 2008, please amend the above identified application as follows:

Amendments to the Claims are reflected in the listing of claims in the paper.

Remarks follow the amendment section of this paper.